

UNITED STATES DEPARTMENT OF COMMERCE

PATENT AND TRADEMARK OFFICE

PATENT

In the application:

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Inventors:	HE, Ting et al.
Serial Number:	10/757,302
Filed:	January 14, 2004
For:	HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM FOR MATERIAL COMBINATORIAL STUDIES
Group Art Unit:	1763
Examiner:	Richard R. Bueker
Atty. Docket No.:	3994994-148069
Confirmation No.:	4457

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**RCE and Amendment in Response to Final Office Action Mailed 11/22/2010**

*By E-file [registered user]* on MARCH 21, 2011  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

To the Honorable Commissioner:

This Request for Continued Examination (RCE) and Amendment is filed in response to the Office Action mailed 11/22/2010. Please consider the remarks and amendments herein prior to further examination of the above-identified application.

This response includes:

- 1) Amendments to the Claims begin on page 2; and
- 3) Remarks begin on page 6.

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